

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Docket No: Q77911
Hideya TAKEO et al	Conf. No.: 3651
Appln. No.: 10/684,708	Group Art Unit: 2624
Filed: October 15, 2003	Examiner: Motsinger, S.
For: ABNORMAL PATTERN CANDIDATE DETECTION PROCESSING METHOD AND SYSTEM	

AMENDMENT UNDER 37 C.F.R. § 1.114(c)

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 22, 2007, please amend the above-identified application as follows on the accompanying pages.

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